

Figure 1. Schematic diagram of Si:HfO₂ deposition method. Hf sub-cycle means HfO₂ sub-cycle, and Si sub-cycle means SiO₂ sub-cycle, respectively.

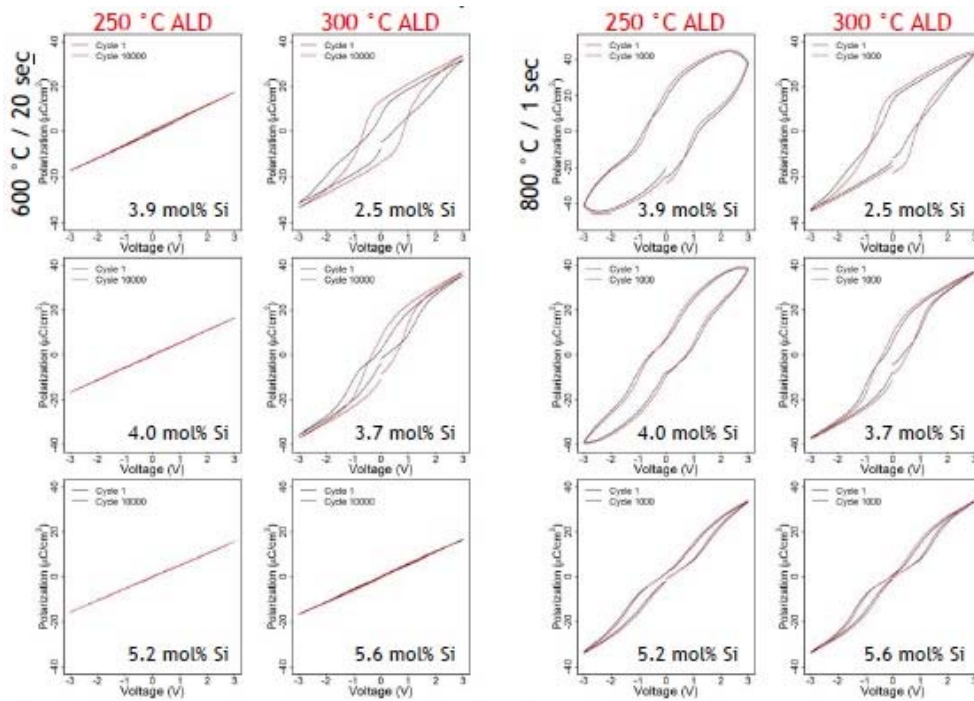


Figure 2. FE characteristics of FeRAM devices with various mol % Si and RTP conditions.